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Sheet 1 of 1

FORM 1449* INFORMATION DISCLOSURE STATEMENT IN AN APPLICATION (Use several sheets if necessary)	Docket Number: STFD.039PA	Application Number: 10/663,935
	Applicant: EL GAMAL et al.	
	Filing Date: 09/16/2003	Group Art Unit: 2886

U.S. PATENT DOCUMENTS							
EXAMINER INITIAL	DOCUMENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE	
/HP/	4,841,348	6/20/1989	Shizukuishi	999	030		
↓	5,073,029	12/17/1991	Eberly	356	432		
	5,461,425	10/24/1995	Fowler	348	294		
	5,942,775	8/24/1999	Yiannoulos	257	292		
	6,085,576	7/11/2000	Sunshine	073	029.010		
	6,150,189	11/21/2000	Pan	438	059		
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	6,784,982	8/31/2004	Blumenfeld	356	071		
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	/HP/	7,145,645	12/05/2006	Blumenfeld	356	073	
FOREIGN PATENT DOCUMENTS							
	DOCUMENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
/HP/		Chamberlain, Savvas G., "Photosensitivity and Scanning of Silicon Image Detector Arrays", IEEE Journal of Solid-State Circuits, Vol. SO-4, No. 6, December 1969.					
/HP/		Noble, Peter J., "Self-Scanned Silicon Image Detector Arrays", IEEE Transactions on Electron Devices, Vol. Ed. 15, No. 4, April 1968.					

EXAMINER	/Hoa Pham/	DATE CONSIDERED	04/22/2009
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form for next communication to the Applicant.			